



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#7/DIC
3/12/3
Susler

In re PATENT Application of
Lu

Group Art Unit: 2813

Application No. 09/838,316

Examiner: Chen

Filed: April 20, 2001

Att. Docket No.: 95-153

For: METHOD FOR FABRICATING SILICON-ON-INSULATOR MATERIAL

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February 27, 2003

DRAWING CHANGE AUTHORIZATION REQUEST

Hon. Asst. Commissioner of Patents
and Trademarks
Washington, D.C. 20231

Sir:

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Please enter new Figs. 1A, 1B, 1C, 2A, 2B, 3A, 3B, and 3C as attached herewith. New Figs. 1A-3C do not add new matter. Support for new Figs. 1A-3C can be found in the originally filed application, including at page 10, line 3 through page 15, line 29.

Please renumber Figs. 1-7 as Figs 4-10, respectively, as shown in the attached Figs. 4-10. A red-inked copy of the original Figs. 1-7 is also attached showing the renumbering and deletion of reference to "1/2" and "2/2". No new matter has been added.

An early and favorable action on the merits is respectfully requested.

Respectfully submitted,
Manelli Denison & Selter PLLC

By

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